



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Udagawa

Application No. 10/004,646

Filed: December 3, 2001

Confirmation No. 6774

For: DEVICES AND METHODS FOR
MONITORING RESPECTIVE
OPERATING TEMPERATURES OF
COMPONENTS IN A
MICROLITHOGRAPHY APPARATUS

Examiner: Christopher M. Kalivoda

Art Unit: 2881

Attorney Reference No. 4641-61503

COMMISSIONER FOR PATENTS
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CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney
for Applicant(s)

Donald L. Stenberg

Date Mailed October 17, 2003

AMENDMENT AND REPLY TO OFFICE ACTION

This responds to the Office action dated April 18, 2003. Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims are reflected in the listing of claims, which begins on page 4.

Amendments to the Drawings begin on page 10, and include the attached replacement sheet.

Remarks begin on page 11.

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